

Serial No. 09/928,474



[Signature]

Docket No.: 006301 USA/Consilium/Consilium

PATENT/OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Badri N. KRISHNAMURTHY et al. :
Serial No. 09/928,474 : Group Art Unit: 2812
Filed: August 14, 2001 : Examiner: Andre' C. Stevenson

For: EXPERIMENT MANAGEMENT SYSTEM, METHOD AND MEDIUM

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This submission does not constitute a representation that a search has been made or that no better art exists and does not constitute an admission or representation that any of the listed documents is material or constitutes prior art. If it should be determined that any of the listed documents does not constitute prior art under the United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such

Serial No. 09/928,474

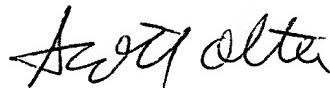
document.

The references listed on Sheet 1 of the attached PTO-1449 Forms were cited in a patentability investigation and/or a corresponding foreign or PCT application relating to the above-referenced application. The remaining references are from potentially related patent applications, and possibly other sources.

This Information Disclosure Statement is being filed after a Request for Continued Examination, before the mailing date of a first Office Action on the merits or Notice of Allowance. No certification or fee is required.

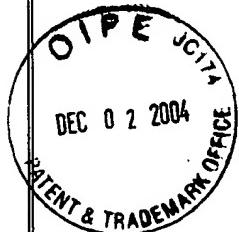
Respectfully submitted,

Wilmer Cutler Pickering Hale and Dorr LLP



Scott M. Alter
Registration No. 32,879

Reston Town Center
11951 Freedom Drive
Reston, VA 20190
TEL (703) 654-7021 SMA/mgm
FAX (703) 654-7100
Date: 12/2/04

<p style="text-align: center;">INFORMATION DISCLOSURE CITATION IN AN APPLICATION</p> <p style="text-align: center;">(PTO-1449)</p> 				ATTY. DOCKET NO. 006301 USA/ Consilium/Consilium		SERIAL NO. 09/928,474	
				APPLICANT Badri N. KRISHNAMURTHY et al.			
				FILING DATE August 14, 2001		GROUP 2812	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
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FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	WO 01/01205 A2	01/04/01	WIPO			X	
	GB 2 363 477 A	12/19/01	United Kingdom			X	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
	Rauf, Shahid and Mark J. Kushner. August 1998. "Virtual Plasma Equipment Model: A Tool for Investigating Feedback Control in Plasma Processing Equipment." <i>IEEE Transactions on Semiconductor Manufacturing</i> . Vol. 11, No. 3. pp. 486-494.						
	Rauf, Shahid and Mark J. Kushner. May/June 1999. "Controller design issues in the feedback control of radio frequency plasma processing reactors." <i>J. Vac. Sci. Technol. A</i> . Vol. 17, No. 3. pp. 704-712.						
	Cruden, Brett et al. "Chemical Vapor Deposition (CVD) of Teflon & trade-like Films for Use in Low-k Interlayer Dielectric Applications." http://plasma-processing.com/chemvap .						
	Kim, Jiyoun et al. "Gradient and Radial Uniformity Control of a CMP Process Utilizing a Pre-and Post-Measurement Strategy." <i>University of Michigan, Electrical Engineering and Computer Science Department</i> .						
	November 11, 2004. International Search Report for PCT Serial No. PCT/US03/36501.						
EXAMINER			DATE CONSIDERED				

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)			
November 17, 2004. Written Opinion for PCT Serial No. PCT/US01/27407.			
EXAMINER		DATE CONSIDERED	

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